



**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant: Craig K. Carlson-Stevemer

Examiner: Jermele M. Hollington

Serial No.: 10/622,849

Group Art Unit: 2829

Filed: July 18, 2003

Docket No.: A126.114.102

**Due Date: September 3, 2006**

**Title: WAFER STAGING PLATFORM FOR A WAFER INSPECTION SYSTEM**

**AMENDMENT AND RESPONSE**

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir/Madam:

This Amendment and Response is in reply to the Non-Final Office Action mailed May 3, 2006. Please amend the above-identified patent application as follows: